



Docket No.:0756-7293

IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Koichiro TANAKA, et al. )  
Serial No. 10/827,449 ) Group Art Unit: 2874  
Filed: April 20, 2004 ) Examiner: Michael Stahl  
For: BEAM HOMOGENIZER, LASER )  
IRRADIATION APPARATUS, AND METHOD FOR )  
MANUFACTURING SEMICONDUCTOR DEVICE )

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
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P. O. Box 1450, Alexandria VA 22313-1450, on February 3, 2006

Jimmy L. Dunn

**SECOND REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

  
Eric J. Robinson  
Reg. No. 38,285

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